

PATENT

Docket No.: M4065.0139/P139-A

Micron No.: 98-0981.01/US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Cem Basceri

Serial No.: Not Yet Assigned  
(Divisional application of Ser. No.  
09/228,293 under rule 53(b))

Group Art Unit: 2812

Filed: Concurrently Herewith

Examiner: Unassigned

For: METHOD FOR IMPROVING THE  
SIDEWALL STOICHIOMETRY OF  
THIN FILM CAPACITORS

Assistant Commissioner for Patents  
Washington, D.C. 20231

**FIRST PRELIMINARY AMENDMENT**

Dear Sir:

Prior to examination on the merits, please amend the above-identified U.S.  
patent application as follows:

In the Specification:

Page 1, after the title, please insert: This application is a divisional of application

Ser. No. 09/228,293, filed on January 8, 1999, which is hereby incorporated by  
reference.--

PAT 6,194,229

In the Claims:

Please cancel claims 1-38 and 57-73.

09633132-080400